



GP 2812  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:  
Xu et al.

Serial No. 09/854,177

Filed: May 10, 2001

For: METHOD AND SYSTEM FOR  
DETECTING METAL  
CONTAMINATION ON A  
SEMICONDUCTOR WAFER

§ Examiner: Unknown  
§  
§ Group Art Unit: 2812  
§  
§ Atty. Dkt. 5589-00501  
§

*[Signature]*  
#5  
6-10-02

Certificate of Mailing 37 C.F.R. § 1.8(a)	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date below:	
12/20/01 Date	<i>Pamela Gerik</i> Pamela Gerik

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

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It is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. A copy of each listed document is enclosed for the convenience of the Examiner.

Should any fees be required, the Assistant Commissioner is authorized to charge said fees to Conley, Rose & Tayon, P.C. Deposit Account No. 50-1505/5589-00501.

Respectfully submitted,

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Date: 12/20/01